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NOV 0 6 2003

PATENT APPLICATION

PATENT AND TRADEMARK OFFICE

Technology Center 2100

Applicants: Chin et al.

Case: 5017/ISM/CORE/MCVD/SB

Serial No.: 09/917,842

Filed: **July 27, 2001**

Examiner: Alexander J. Kosowski

Group Art Unit: 2125

Title: ATOMIC LAYER DEPOSITION APPARATUS

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

RESPONSE ACCOMPANYING RCE

Please enter this Response Accompanying RCE filed in response to the Office Action dated July 29, 2003 (Paper No. 7), having an extendable shortened statutory period expiring October 29, 2003. Please reconsider the claims pending in the application for the reasons discussed below. The Commissioner is authorized to charge Deposit Account No. 20-0782 for any other fees required to make this response timely and acceptable to the Office.